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Optics and photonics - Test methods for surface imperfections of optical elements (ISO 14997:2011)

Contents		Page
National foreword		3
National Annex NA (informative) Bibliography		4
Introduction		5
1	Scope	6
2	Normative references	6
3	Terms and definitions	6
4	Physical principles	7
5	Measurement of obscured or affected area	7
5.1	General	7
5.2	Requirements	9
5.3	Calibration	9
5.4	Procedure	9
5.5	Test report	9
Annex A (informative) Component inspection		11
Annex B (informative) Recommended dimensions of artefacts on a scale comparison plate		12
Annex C (informative) Description of the instrument used for measuring imperfections below 0,01 mm: microscope image comparator		13
Annex D (informative) Imperfection quality control		16
Annex E (normative) Preferred values of grade numbers and subdivision factors		18
Bibliography		19